

# Activities in Task 14.3.1: Infrastructure for Silicon Calorimeters

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**AIDA-2020 4<sup>th</sup> Annual Meeting,  
Oxford, UK  
03/04/2019**



# DESY-2017 beam test

7 SLAB's FEV11  $\supset$  325  $\mu\text{m}$  Wafers

Commissioning paper ready submitted  
(NIM + ArXiv: OpenAccess)

- Editor: Adrián Irles [LAL/P2IO]
- Limited to «low energy» response: mip and noise
- Submitted to NIM (Jan); in discussion with referees
  - Includes AIDA-2020 and labex P2IO acknowledgement
  - related to procedure of DQ of WP14.3.1

2 **Commissioning of the highly granular SiW-ECAL**  
3 **technological prototype**

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4 *E-mail:* [irles@lal.in2p3.fr](mailto:irles@lal.in2p3.fr)

5 **ABSTRACT:** High precision physics at future colliders as the International Linear Collider (ILC)  
6 require unprecedented high precision in the determination of the final state of the particles produced  
7 in the collisions. This precision will be achieved thanks to the Particle Flow algorithms (PF)  
8 which require compact, highly granular and hermetic calorimeters systems. The Silicon-Tungsten  
9 Electromagnetic Calorimeter (SiW-ECAL) technological prototype design and R&D is oriented  
10 at the baseline design of the ECAL of the International Large Detector (ILD) for the ILC. In this  
11 article we present the commissioning and the performance of the prototype in a beam test carried  
12 at DESY in June 2017.

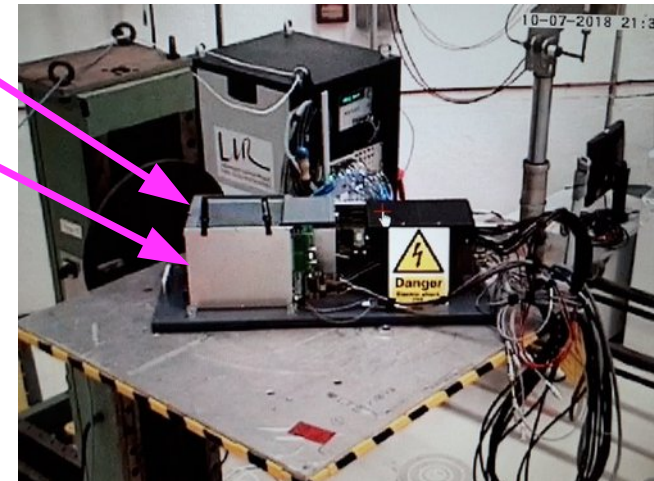
13 **KEYWORDS:** Calorimeter methods, calorimeters, Si and pad detectors

[arxiv.org/abs/1902.00110](https://arxiv.org/abs/1902.00110)

# DESY-2018 beam test

2 weeks beg of July

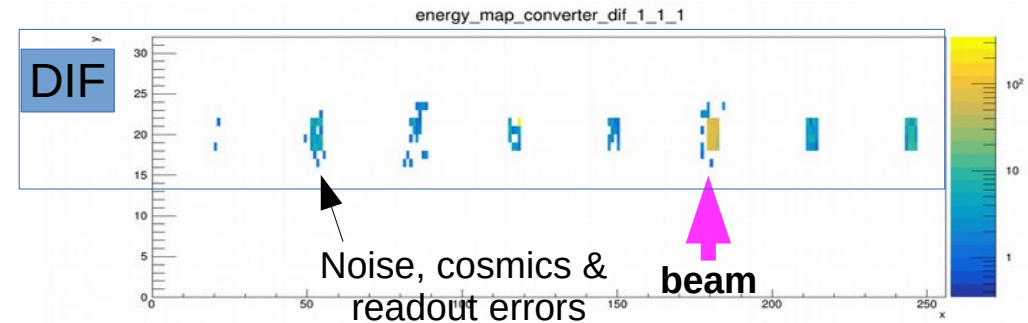
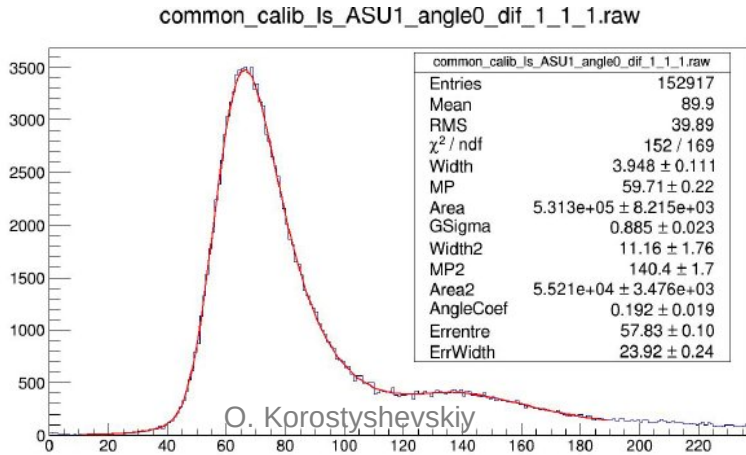
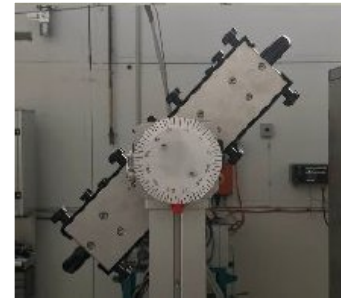
- Electric long slab: 8 FEV12 + babywafers
- "Stack" = 7 FEV11 Shorts slabs  
+ 1 FEV13 (with SMBv5)
  - with 650  $\mu\text{m}$  wafers, SK2A, new design



# Electric “long slab”

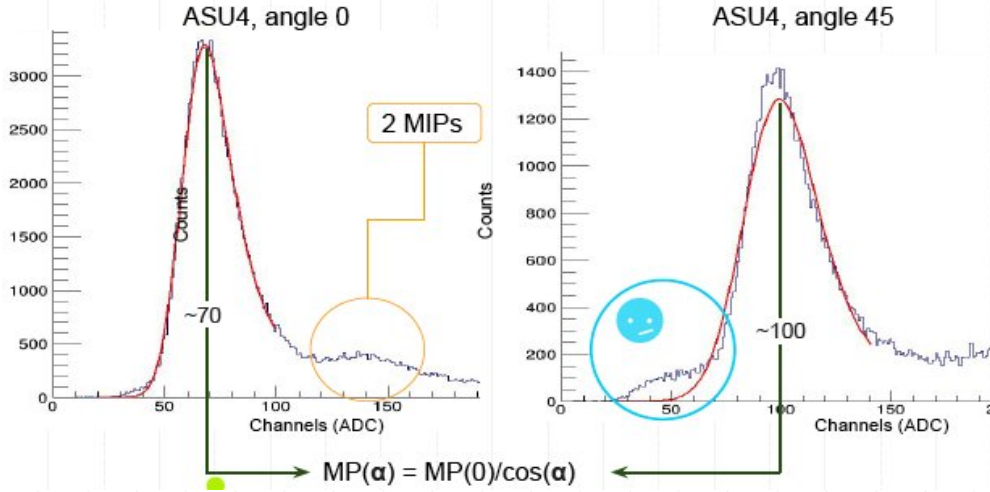
2 weeks beg of July: full test of all prototypes:

- Electric long slab: 8 FEV12 + baby-wafers ( $320\mu\text{m} \times 2 \times 2\text{cm}^2$ ):
- RC Filtering of HV between (every second) boards required
- Very clean response to “mip” (punch through  $e^-$ )

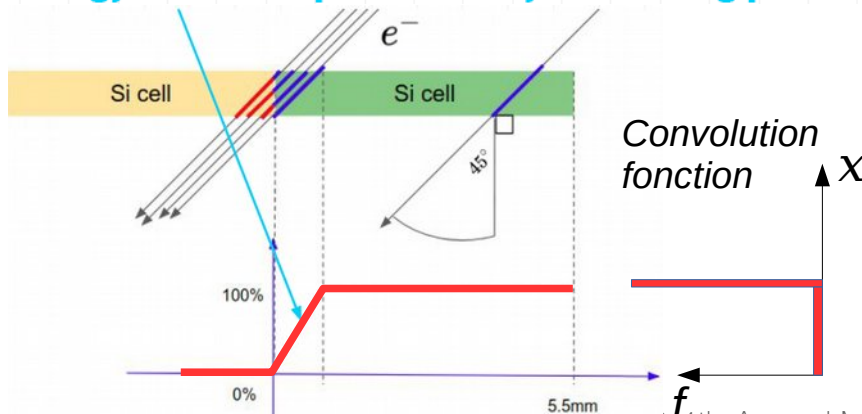


# Mip analysis

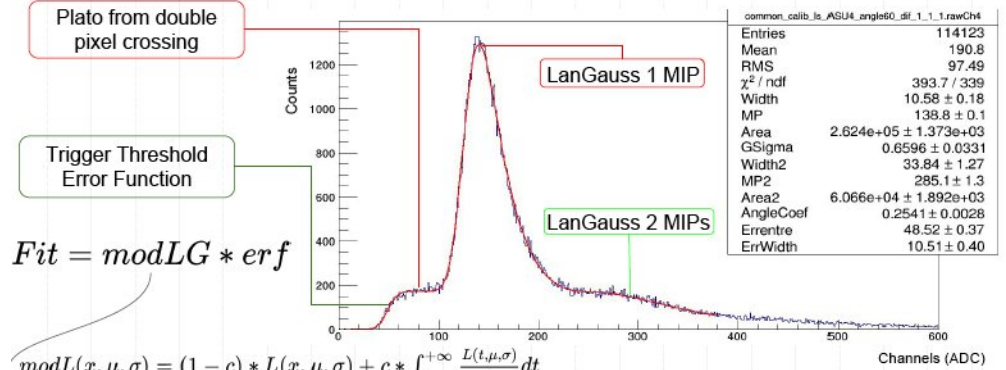
O. Korostyshevskiy



Pixel energy fraction depends linearly on crossing position



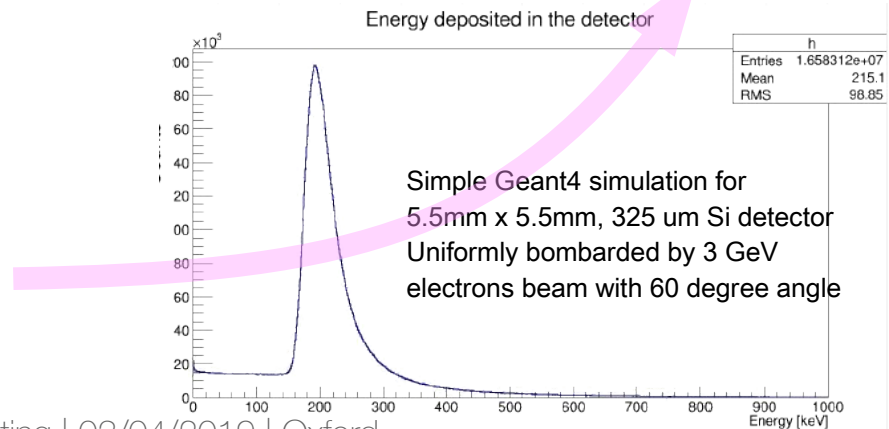
Fit with Mod LanGau function



$Fit = modLG * erf$

$modL(x, \mu, \sigma) = (1 - c) * L(x, \mu, \sigma) + c * \int_x^{+\infty} \frac{L(t, \mu, \sigma)}{t} dt$

$modLG = \int_{-\infty}^{+\infty} modL(t, \mu, \sigma) * G(x - t, \mu_G, \sigma_G) dt$



# MIP response vs position

## mip MPV \*cos(θ) vs ASU#

- OK for 4 1<sup>st</sup> ASU's + Small drop ~of signal ~2%/ASU for ≥ ASU#5
- Also hints similar drop on  $\sigma_{ped}$

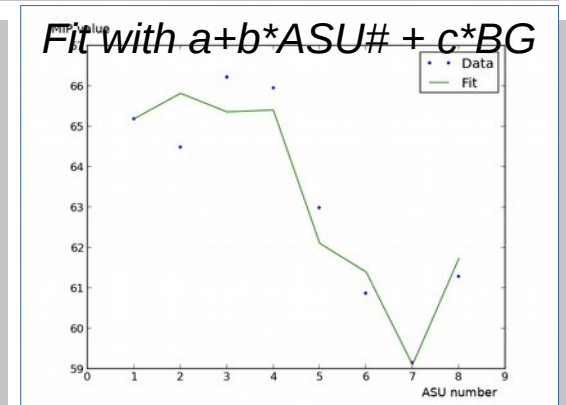
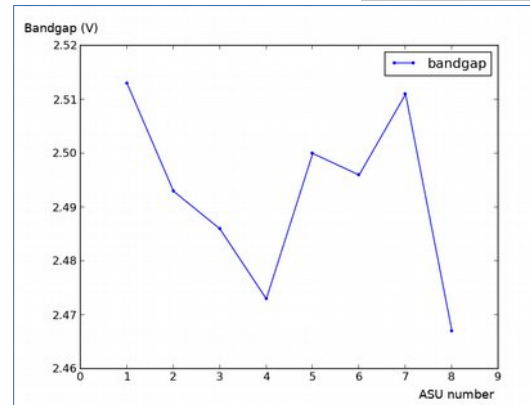
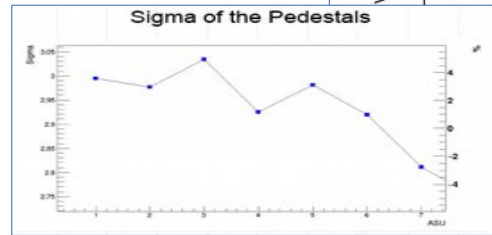
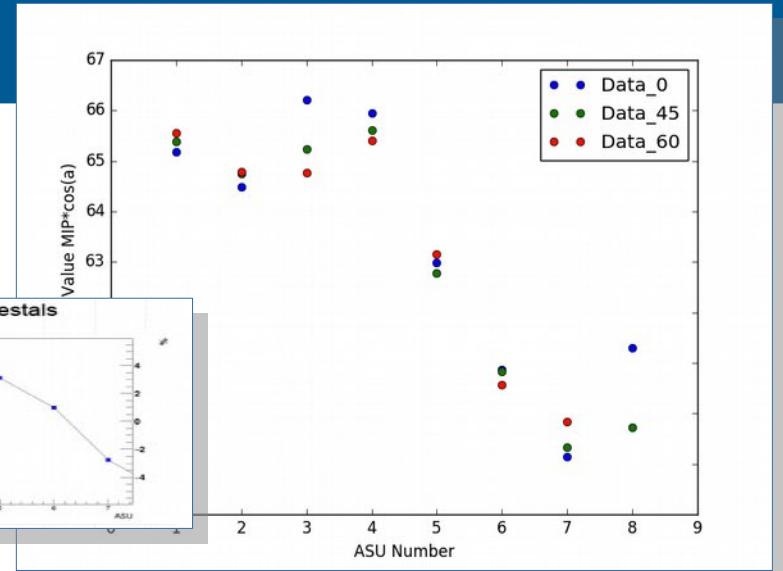
### ⇒ Voltage or Gain drop ?

Power pulsed mode with ballast et end of slab  
or just random build-up effect from chip variability ?

- Answer: Voltage ↘ + Band-gap variability  
Data fitted with
  - linear voltage drop (vs distance)
  - BG variability

Presented @ VCI'2019; paper submitted this week

▷ ack't of support from AIDA-2020 and P2IO



# FEV13

## Only a few masked channels!

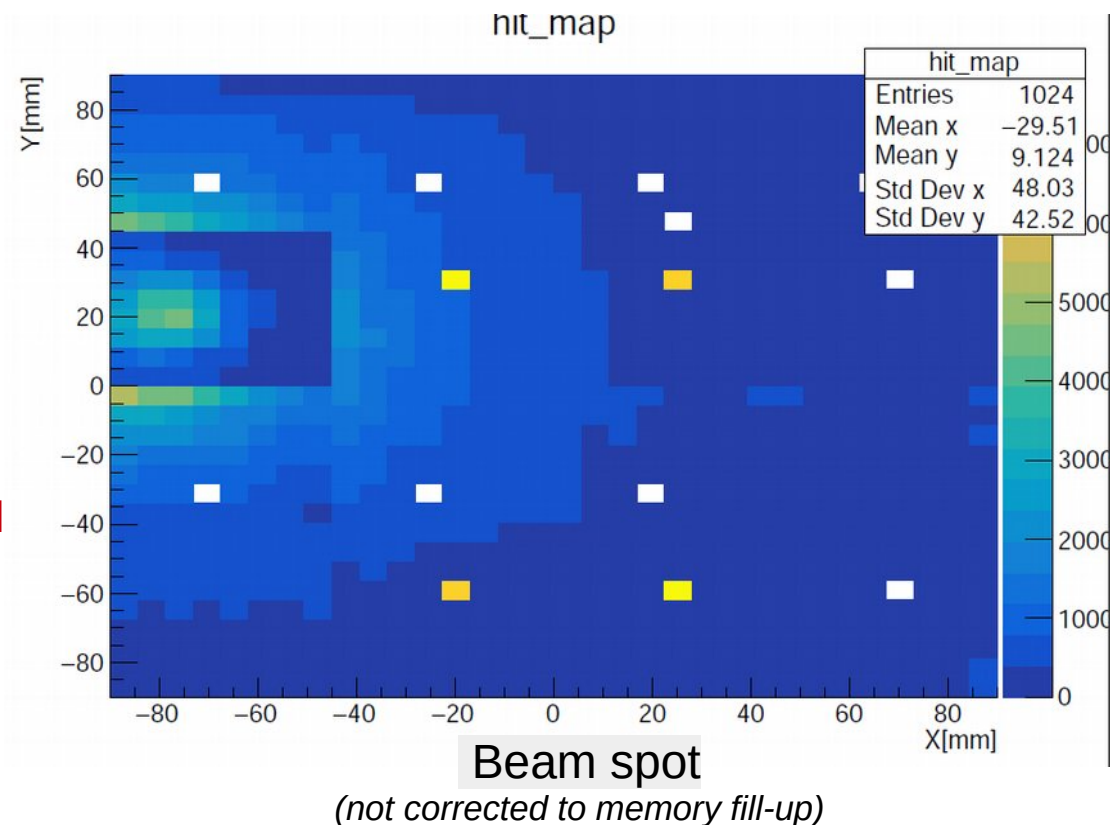
- worked «out of box»

## but instabilities after a couple of days

- 4 new layers produced in Kyushu.
  - $3 \times 650 \mu\text{m} + 1 \times 320 \mu\text{m}$  wafers

## improved S/N handling, TDC enabling

- individual thr adj.
- better noise adjustment → ~ only ch 37 excluded



# FEV13 assembly in Japan

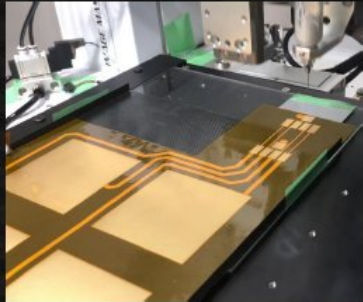
## Assembly procedure



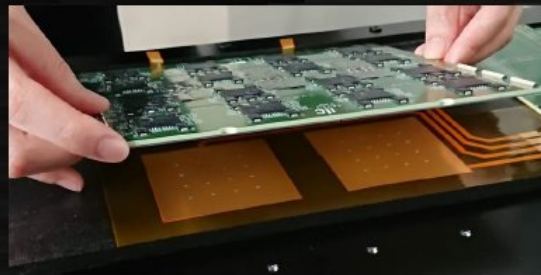
Dispense conductive glue



Place sensors → 1 day cure



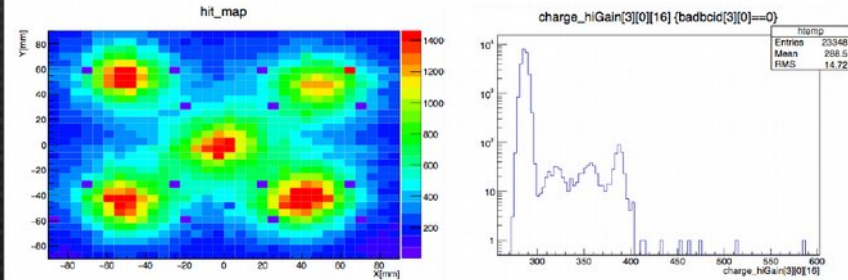
Dispense glue to flex



Mount sensor+PCB → 1 day cure

Similar to production in Paris region  
(AIDA-2020 benches)

## Result ( $^{57}\text{Co}$ )



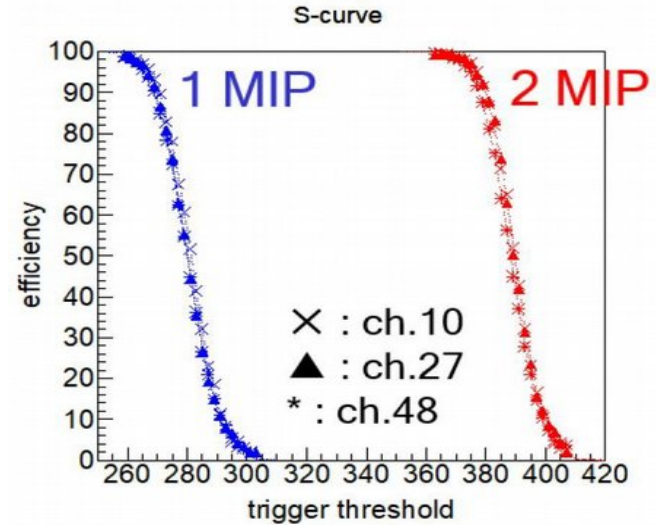
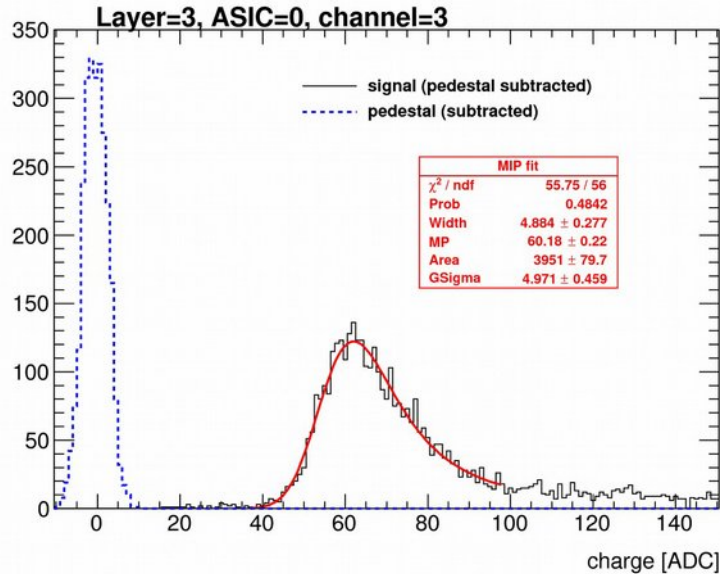
- We can get data now !  
But we have to finish to acquire datas in 4 times, because we have to test 5 SLABs. We already finished only the SLAB.

S/N ratio is about 30.

Improved to 40 in some cases



# Stack: S/N on the trigger line from thr. scan

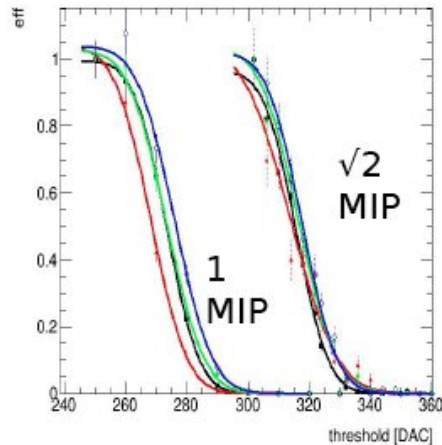


Injected signal → MIP

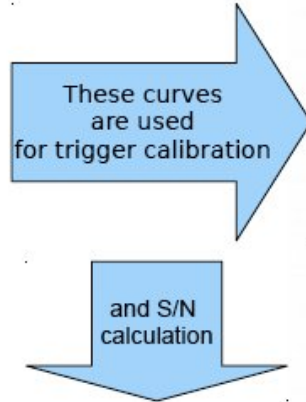
S/N ~ 20 in ADC branch    S/N ~ 12 in Trigger Branch.  
Trigger at 50% mip with  $6\sigma$   
or 1/3 mip with  $4\sigma$

# S/N in the trigger line

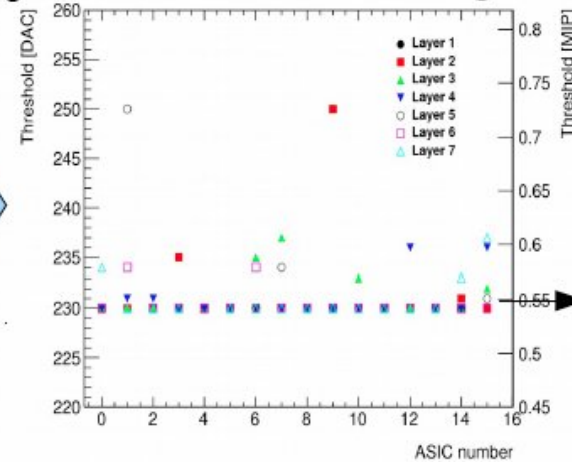
- For autotrigger data taking, a S/N is to be defined by the study of the trigger line (fast shaper in Skiroc) → threshold scans with different signals
  - The threshold scan curve is interpreted as the integral of the gaussian distribution of the noise.



Slab 17, 18, 19, 20 (FEV11)



Trigger thresholds used in DESY@2017&2018



230DAC  
≈ 5σ  
distance  
of the MIP

**S/N = 11.6 ± 0.7** (ILD baseline requirements: S/N=10)

**Trigger threshold at ~0.5 MIP**

**First S/N (trigger) measurements in beam test.**

© A. Irlles, at P2IO day

# Combined BT at CERN 2018

2 weeks on H2-B 25/09–10/10/2018

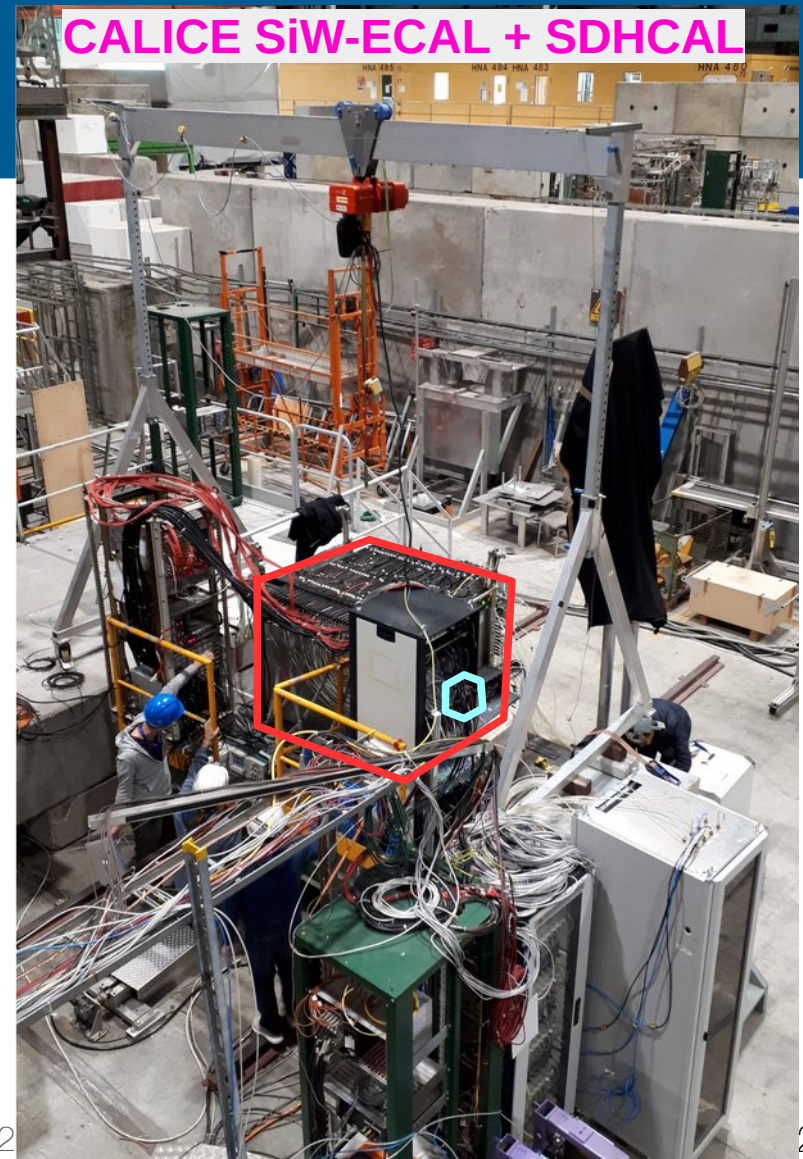
CERN 2018

**SPS:**

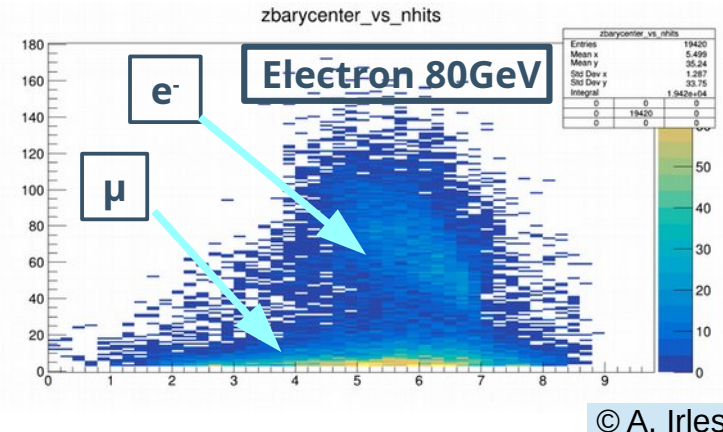
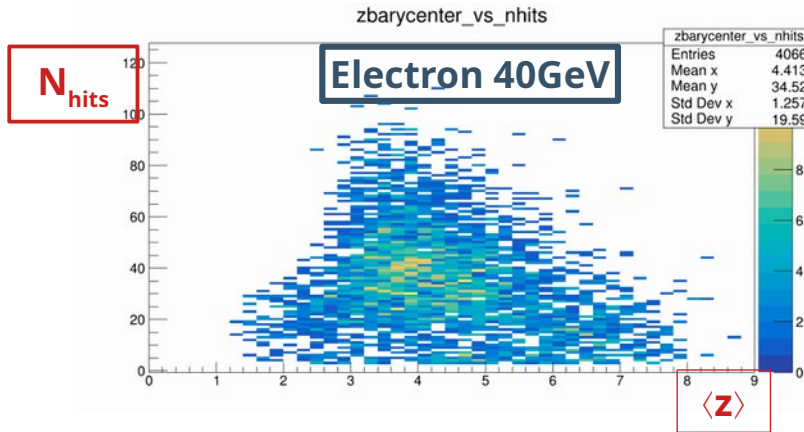
schedule issue date: 05-Sep Version: 2.3.4

Week	38	39	40	41
Machine				
T2 - H2	F. Anulli	LEMMA	Calice (Sdhcal) I. Laktineh	Calice (Sdhcal) D. Lazic
T2 - H4	F. Cavanna	NP04	NP04 D. Lazic	CMS ECAL F. Cavanna

- 37 layers of SDHCAL RPC, 5MHz clock
- 10 layer of SiW-ECAL : 6 FEV11 and 4 FEV13.
  - 2.5 MHz (all FEV11 but 1) and 5.0 MHz (FEV13+1FEV11)
  - many issues with FEV13:
    - partial commissioning at LLR bef. BT
    - insecure transport (in plane) → repair on-site, esp. HV connections
  - 1 FEV13 has been working reliably



# Standalone runs



© A. Irls

## Muons and electrons run

- low contamination, except @ High E.
- shower analysis still to be done (also for DESY tests)

These are the statistics for electron data. Obtained from the zbarycenter vs nhits plots.

energy	total events	electrons shower like events
10 GeV	630	~630 (very low contamination)
20 GeV	4060	~3480
40 GeV	2023	~1800
80 GeV	19420	~8000
150 GeV	8474	~1000

# CERN-2018 Combined runs

## Required some work on DAQ:

- HW and SW synchronisation
- Solution of CERN-2016 + 40 MHz clock on both
- first combined test this week (since 2016) but very limited manpower availability
  - shared Spills (and event number), separate clocks

## Reconstruction:

- Data:
  - ECAL = #sp, #bx\_e
  - SDHCAL = cc (absolute bx@sp\_start), #sp, #bx\_h
- Procedure (to be done)
  - 1. Extract cc form SDHCAL event
  - 2. rec. times in ECAL and HCAL
    - $\text{time\_in\_sp} = \text{cc} + f\_freq * \#bx\_i + \Delta s$
  - 3. check linearities ( $\Delta f + \Delta \text{syst.}$ )
  - 4. rec. ECAL + HCAL

**1<sup>st</sup> common meet 18/12/18**

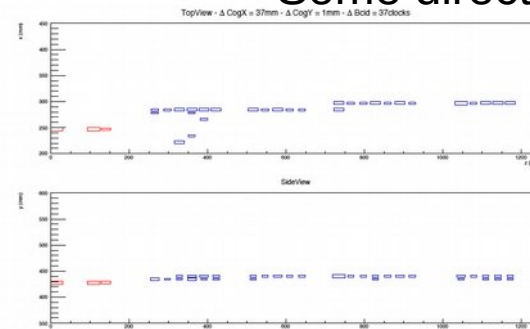
- Selection:  $\text{nslabs\_with\_hit} \geq 3$
- Plot for PiPlus\_50GeV (offset from e-log)

**VERY PRELIMINARY**

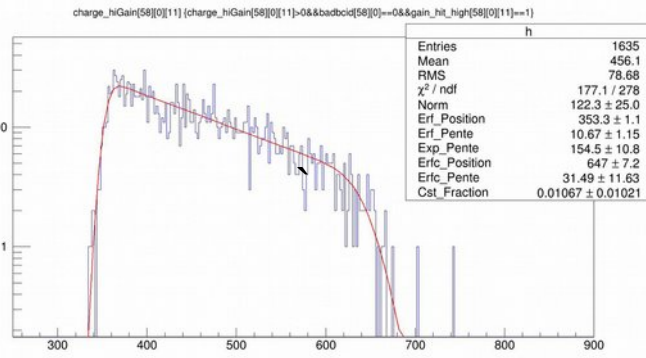
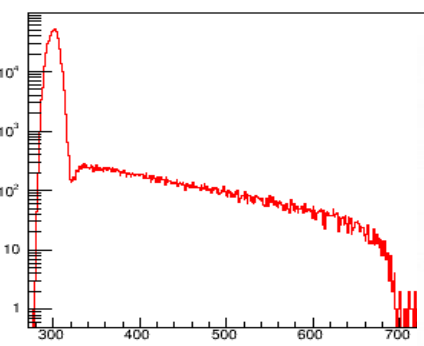
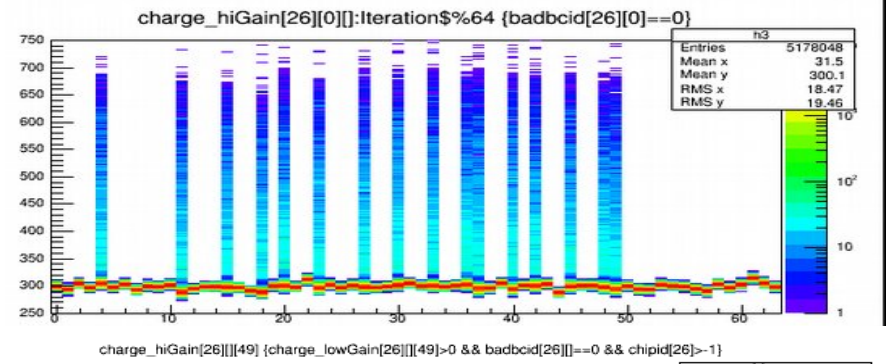
Common runs (selection = nslabs with hit >3)		
run	events (offsets e-log)	events (offsets twiki)
PiPlus_40GeV	28299	not calculated
PiPlus_50GeV	3241	not calculated
PiPlus_60GeV	2365	not calculated
PiPlus_70GeV	12727	not calculated
PiPlus_80GeV	5484	not calculated
Muon_200GeV	108729	89506
Electron 150 GeV	not copied to the cern eos	
Standalone last muon ruon	not copied to the cern eos	

## Event Display

“Some direct coincidences”

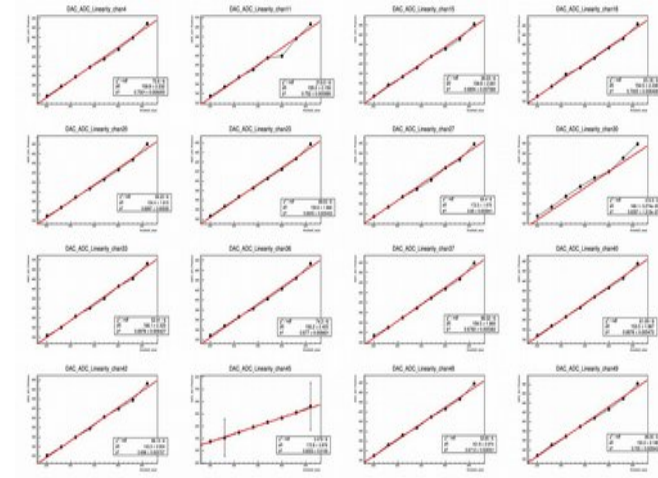


# Test with $^{137}\text{Cs}$ source



Allows for thres. scans down to noise

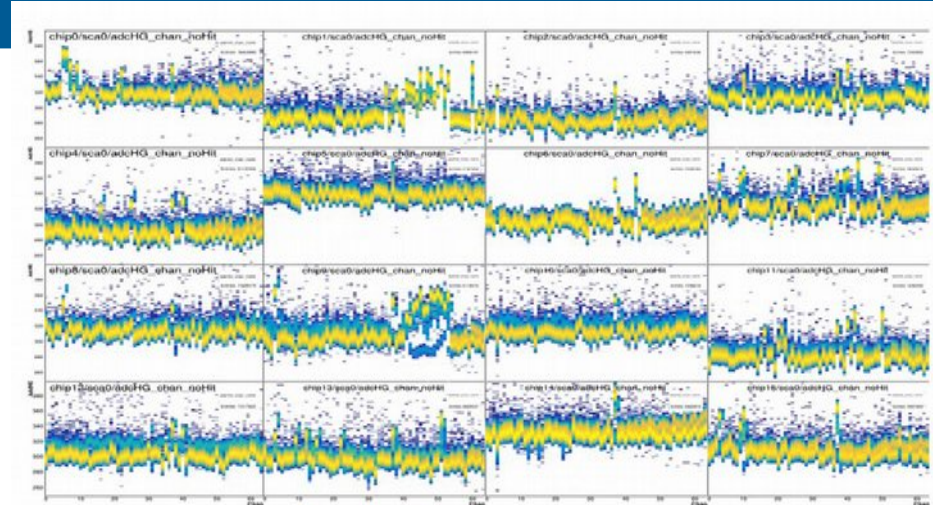
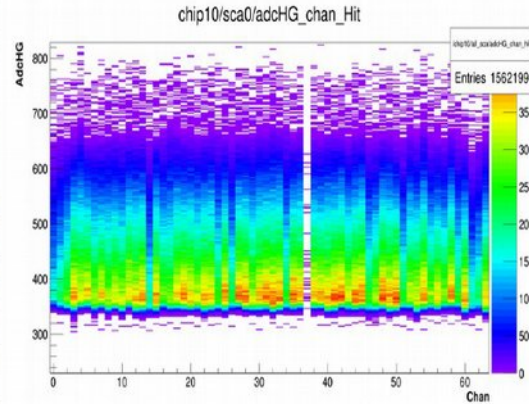
Calibration on Compton edge (477keV ~ 4 mips)



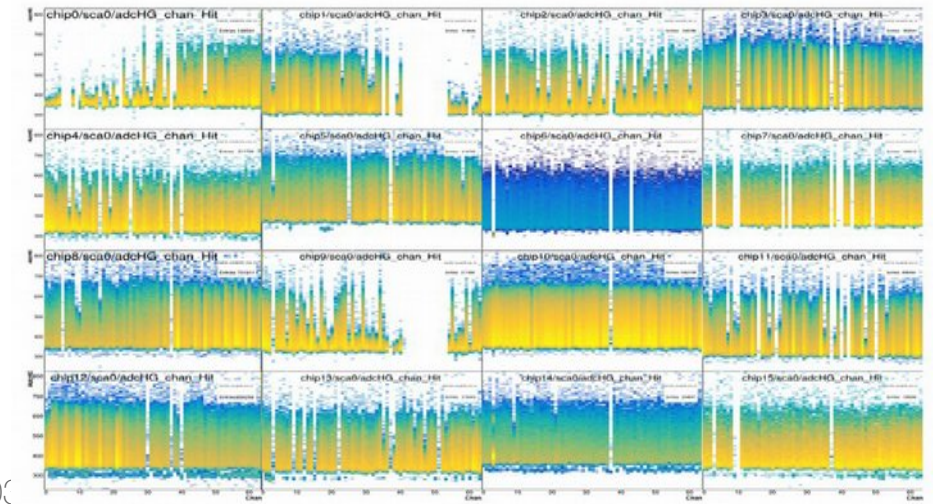
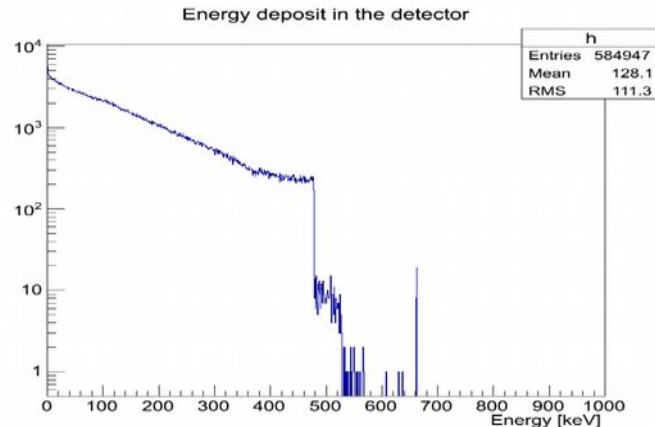
Spectrum in hours with 250kBq source

calibration at ~5 mips in all chans + pedestal

# Full stack irradiation with 37MBq source



- Source  $^{137}\text{Cs}$ , 37MBq
- $D \sim 10$  cm
- Acquisition time = 60000 s
- Threshold 240



# Ultra thin PCB: Chip On Board

## LAL/OMEGA collaboration with Corean Group of SKKU (EOS company for the PCB)

- FEV11\_COB: 10 boards of 1.2mm, good planarity and good electrical response.
- SK2a wirebonded at CERN (Study by LPNHE and P2IO Platform CAPTINNOV)

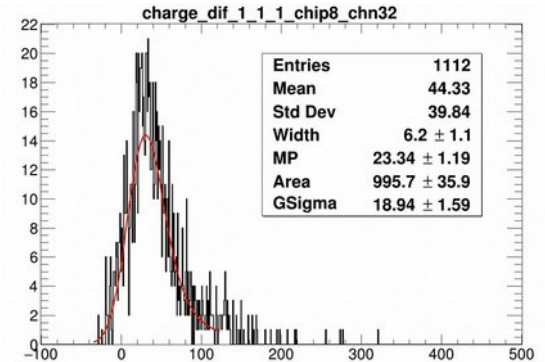
## Successful debugging w/o sensors:

- (~4% of noisy channels, good response to injected signals)

## Debugging with sensors (baby wafers 3×3 px)

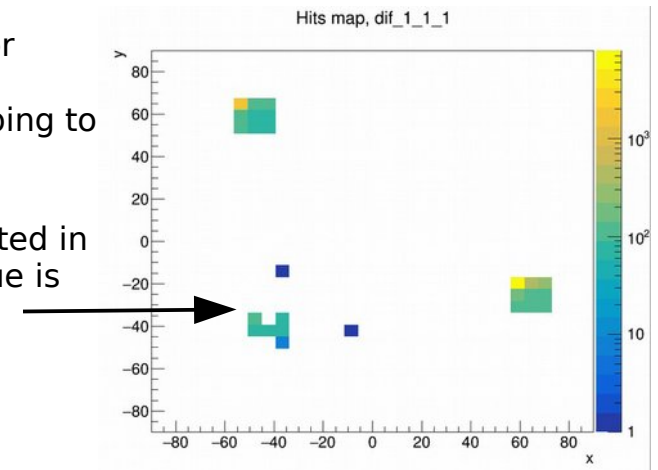
- The system was not ready for test at DESY@2018.
- New wafer testbench setup in LAL borrowed from LPNHE.
- Duplication ongoing at LAL (using the CAPTINNOV platform)
- 3 baby wafers characterized, glued and tested with cosmics. Test with radioactive sources are in preparation.

Example of MIP spectrum from cosmic ray (3.6pF)  
**Plot from V. Lohezic**



Hit map with for cosmic runs (different mapping to BGA versions)

Baby wafer tested in DESY. Some glue is spilled.

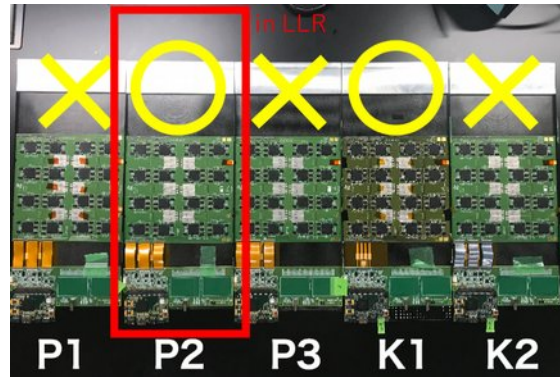




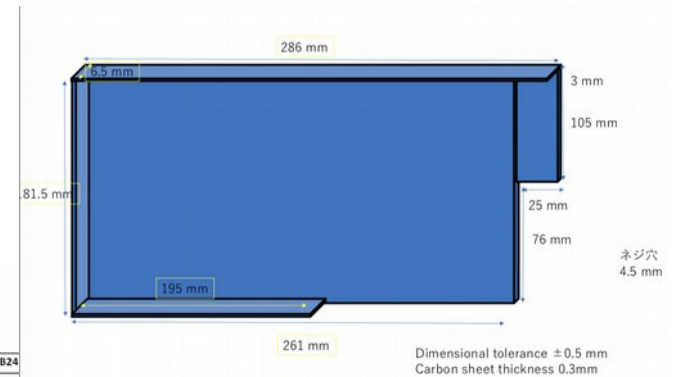
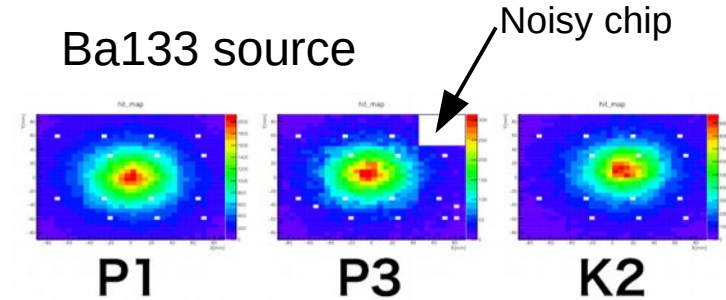
# Other news

## FEV13 with improved mechanics (FEV13 slab dismantled and repaired in Kyushu)

- all HV faults due to repairs



## Ba133 source



## 2 weeks of BT at DESY in 2019:

- 24/06 – 07/07/2019
- COB tests
- FEV13



DESY Test Beam Schedule 2019 - Version 2 15/11/2018

Ralf Diener, Norbert Meyners, Marcel Stanitzki - DESY Test Beam Coordinators

Week	TB21		TB22		TB24/1		TB24	
	DATE	STATUS	DATE	STATUS	DATE	STATUS	DATE	STATUS
10-Jun-19	24	CLIC PIXEL	X	ATLAS-ITk-Strips	X	T2K		
17-Jun-19	25	TBMST	X	ATLAS-ITk-Strips	X	T2K		
24-Jun-19	26	CMS-Pixel-Phase2	X	AFP-TOF	X	CALICE-SIW-ECAL		
1-Jul-19	27	CMS-Pixel-Phase2	X	Mu3e	X	CALICE-SIW-ECAL		
8-Jul-19	28	GammaMeV	X				CALICE AHCAL	
15-Jul-19	29	CLIC PIXEL	X				CALICE AHCAL	
22-Jul-19	30	X-Ray-Crystal-Rad	X					

# Way forward (2019)

## COB adaptations → for June BT



- Gluing of wafer(s) on COB PCB's [@LPNHE]
  - requires the adaptation of the gluing bench
- Testing of boards [@LAL]
  - requires the adaptation of the "versatile bench"
    - for GradConn Connectors

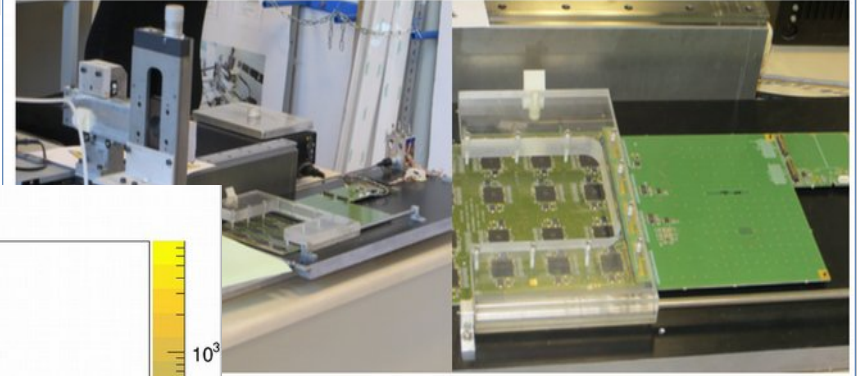
## Work on assembly bench

- Check alignment option with connectors (was Kaptons)
- 2 producers:
  - GradConn
  - Antalec (near Orsay)

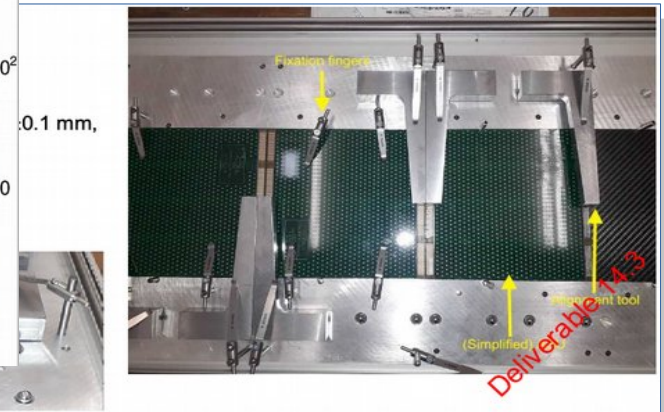
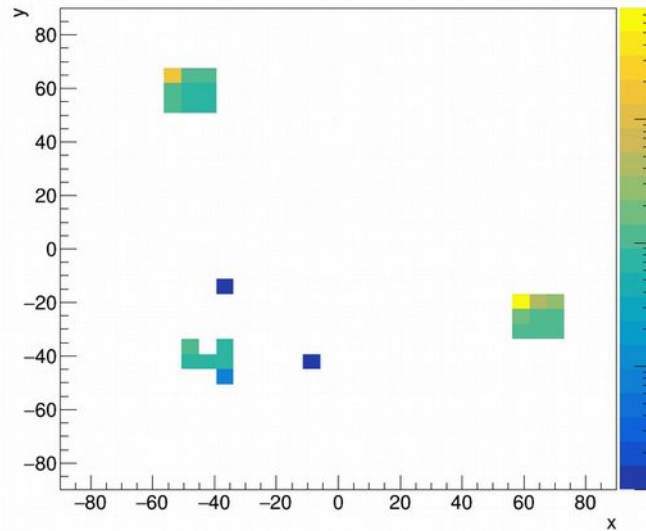
## Improve testing procedures

## Electrical tests bench

- A dedicated electrical test system is used
  - to control the wafers before gluing
  - to check the short cuts immediately after gluing
  - to measure the I(V) curves of each wafer and all 4 wafers
- sourcemeter Keithley 2450 + LLR Bench



Hits map, dif\_1\_1\_1



# DAQ improvement: FW & SW

## Fast Clock

- adjustable at 40 or 50MHz (Collab with HGICAL)
- off during acquisition

## Unique Hardware identification (from Yu Miura, Kyushu)

## Spill number injection from outside

## EUDAQ2 module (in collaboration with Adrian)

## online DD4HEP monitoring

to be done.

# Back-up

# New design for “electronic long slab support”

*M. Anduze, F. Magniette, J. Nanni,  
Realisation: G. Fayolle*

## Scale to support electronics

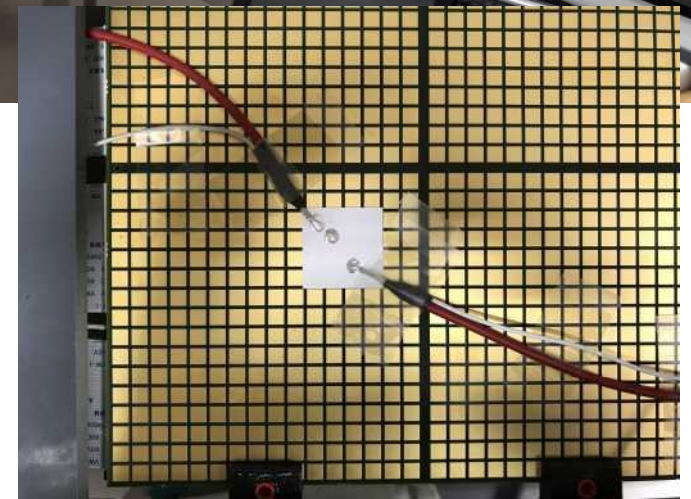
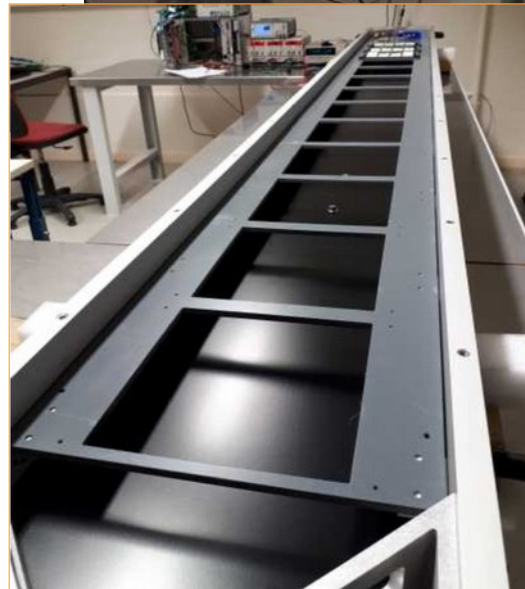
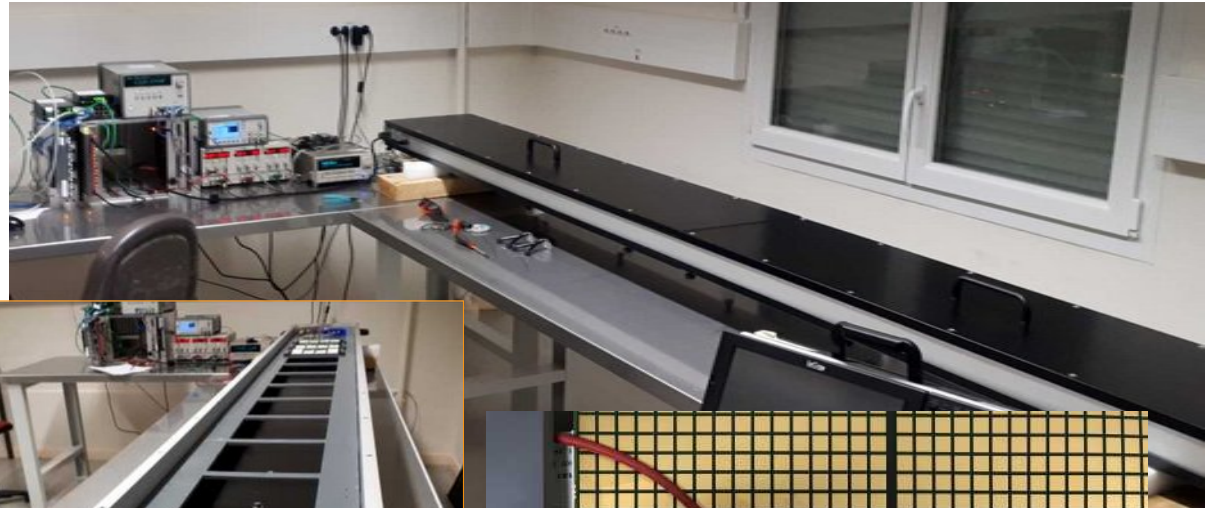
- 2+6+4 ASUs = ~3.2 m
- Support of SMB
- Total access to upper and lower parts
  - Baby wafers (4x4 pixels) on the bottom

## Mechanical characteristics

- Movable: table and to beam test
- Rotatably along long axis (for beam test)
- Rigidity :  $\leq \sim 1$  mm per ASU
- No electrical contacts scale / cards

## Shielding

- vs Light and CEM



2 weeks program with support from AIDA-2020

7 SLABs in 2–5 GeV electron beam, on movable stage

- with and with W absorbers (3 ≠ configurations) @ 0 & 45°
- 1 SLAB with 0–1 T magnetic field
- Conservative commissioning > Masking of noisy channels : 6-8% of channels + 1 @ 24% (1 Wafer)

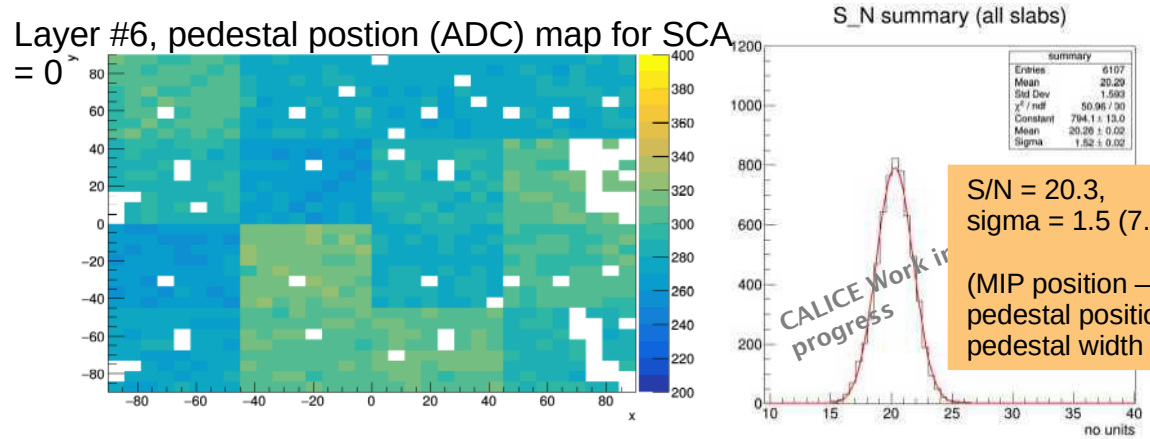
## MIP Scan

- Pedestal correction, Energy calibration channel wise
  - 45° run: MIP value scaling as expected → good thresholds choices.
- Fit the 98% of available channels. Channel dispersion of 5%.

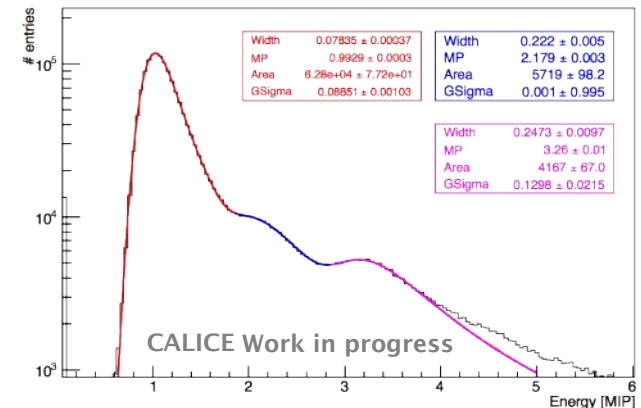
Construction & Commissioning paper(s?) – technical mid 2018 ?

- By layer analysis: mips+noise → noise, S/N, uniformity, ...
  - Presented at CHEF'2017, LCWS'2017, Poster @ IEEE. ← with AIDA support

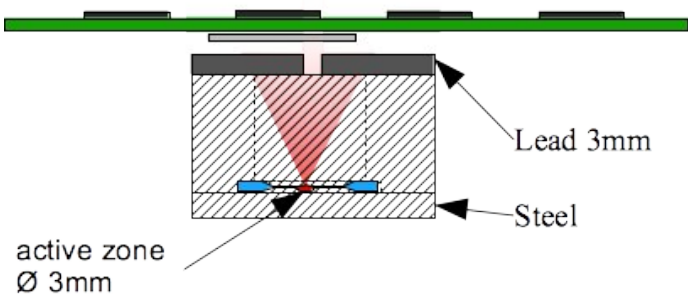
Electron showers to be analysed



Single cell energy distribution for 3 GeV e<sup>+</sup> beam w/o absorber

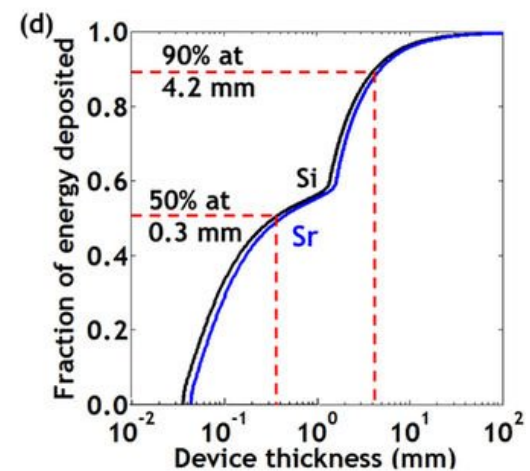
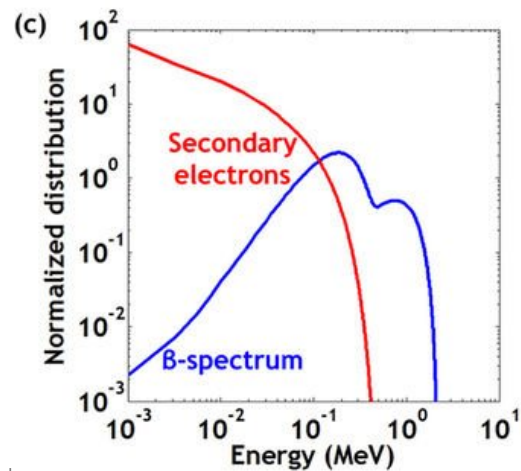
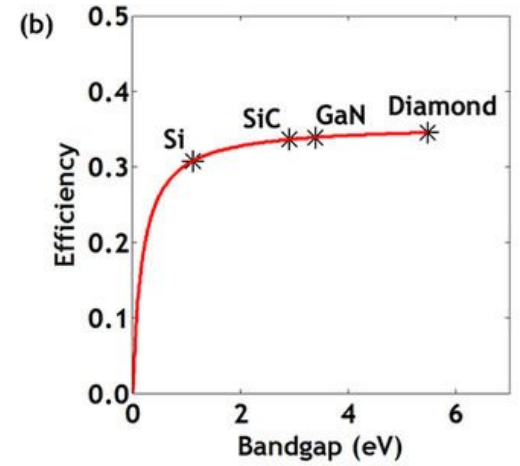
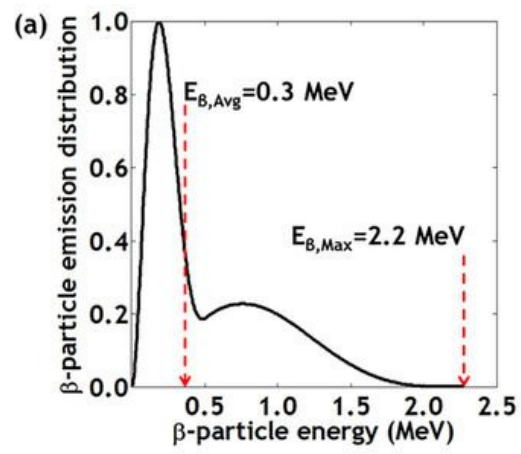
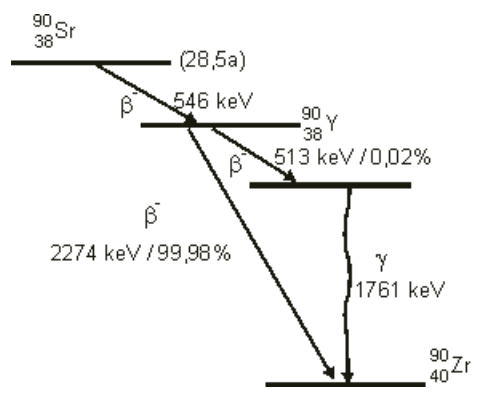


# Test with $^{90}\text{Sr}$ source

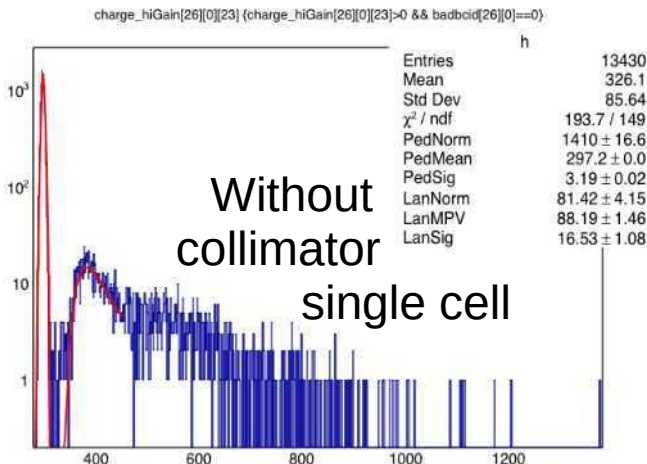
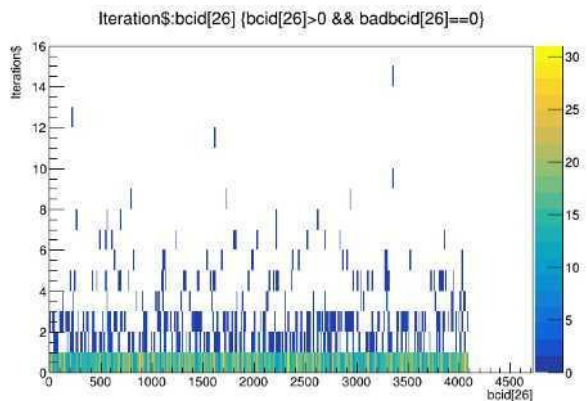
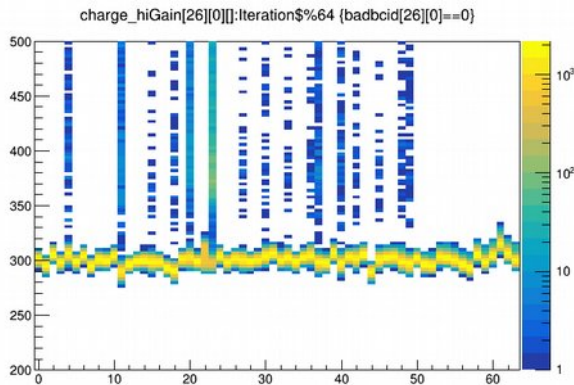


## 2.2 + 0.546 MeV electrons

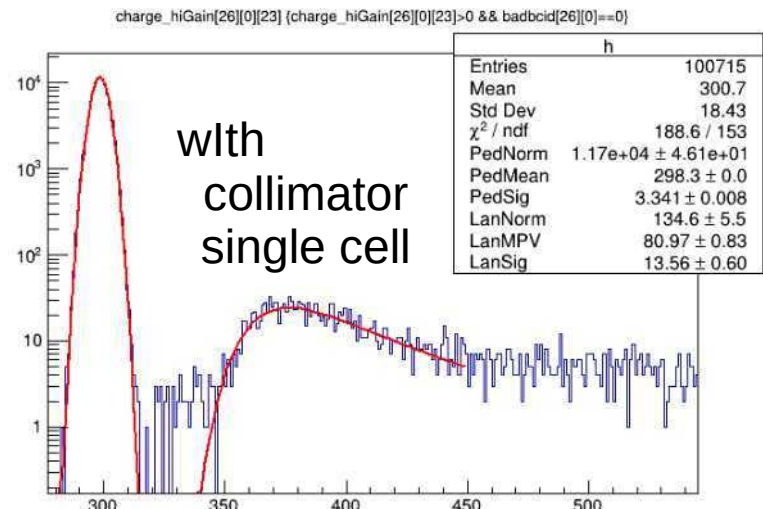
— no straightforward mip but fine...



# Test with $^{90}\text{Sr}$ source



Without  
collimator  
single cell



with  
collimator  
single cell

## Some prelim conclusions:

- Perfect noise cellwise
- punch through electron ~ mip like
- Signal is ~30% higher than in BT (scattering)

## Tested on first 4 ASU's

problem with 5<sup>th</sup> : under investigation

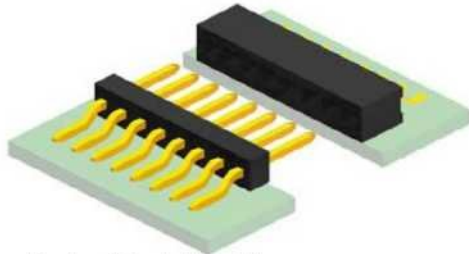


# On interconnection: alternative solutions

"Real" but flat connector

To replace the interconnection kaptons  
on top of board

Height : 1.5 mm (female)  
1.27 – 1.5mm (male)  
Pin distance 1 mm



Breton/Maalmi/Jeglot

<https://www.gradconn.com/Products/BoardToBoard/MatingHalves/BB02-YN/BB02-WF>

Note that connector is compatible for mounting on existing (BGA type) PCB

Studies on connectors also carried out at LLR (J. Nanni) and LPNHE (R. Cornat)

**Expected delivery: Beginning December (1000 units)**

